

AUG 11 2006

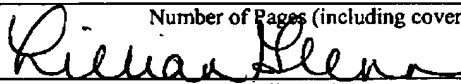
020732-110.694

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****In re United States Patent Application of:****Applicant:** KORZENSKI, Michael B., et al.**Application No.:** 10/807,858**Date Filed:** March 24, 2004**Title:** COMPOSITION USEFUL FOR  
REMOVAL OF BOTTOM  
ANTI-REFLECTION  
COATINGS FROM  
PATTERNED ION-  
IMPLANTED PHOTORESIST  
WAFERS**Docket No.:** 020732-110.694**Examiner:** AHMED, Shamim**Art Unit:** 1765**Confirm. No.:** 5492**Customer No.:****24239****FACSIMILE TRANSMISSION CERTIFICATE****Attn: Examiner Shamim Ahmed****Fax No. (571) 273-8300**

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on August 11, 2006, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

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Number of Pages (including cover)



Lillian Glenn

August 11, 2006

Date

**AMENDMENT RESPONDING TO MAY 11, 2006 OFFICE ACTION IN UNITED  
STATES PATENT APPLICATION NO. 10/807,858**

Mail Stop Amendment  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

This responds to the May 11, 2006 Office Action in the above-identified application.

020732-110.694

Please amend the claims of the application as set out in the following **Section I (Amendments to the Claims)**.

Remarks addressing the substance of the May 11, 2006 Office Action are set out in the **Section II (Remarks)** hereof.